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## BIB DATA SHEET

CONFIRMATION NO. 7682

SERIAL NUMBER	FILING or 371(c) DATE RULE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO. OGOSH46USA		
10/567,729	02/01/2006	257	2814			
<b>APPLICANTS</b> Kazutoshi Kojima, Ibaraki, JAPAN; Satoshi Kuroda, Ibaraki, JAPAN; Hajime Okumura, Ibaraki, JAPAN;						
<b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP04/11894 08/19/2004						
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2003-295413 08/19/2003						
<b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 08/23/2006						
Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 3	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 3
35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No					
Verified and	/SARAH KATE SALERNO/	Initials				
Acknowledged	Examiner's signature					
<b>ADDRESS</b> HOWSON AND HOWSON SUITE 210 501 OFFICE CENTER DRIVE FT WASHINGTON, PA 19034 UNITED STATES						
<b>TITLE</b> Silicon carbide epitaxial wafer, method for producing such wafer, and semiconductor device formed on such wafer						
<b>FILING FEE RECEIVED</b> 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees		
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